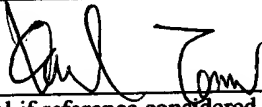


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Sheet 1 of 1

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| FORM PTO-1449 U.S. DEPARTMENT OF COMMERCE | | | | | | | | | | ATTY. DOCKET NO. ONX-106-A | | SERIAL NO. 09/810,336 | |
| LIST OF PRIOR ART CITED BY APPLICANT (Use several sheets if necessary) | | | | | | | | | | APPLICANT Behrang Behin | | | |
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| U.S. PATENT DOCUMENTS | | | | | | | | | | | | | |
| | | DOCUMENT NUMBER | | | | | | | DATE | NAME | CLASS | SUBCLASS | FILING DATE IF APPROPRIATE |
| ht | A | 5 | 9 | 6 | 9 | 8 | 4 | 8 | 10/19/1999 | Lee et al. | 359 | 298 | 07/03/1997 |
| ht | B | 6 | 2 | 1 | 5 | 2 | 2 | 2 | 04/10/2001 | Hoehn | 310 | 309 | 03/30/1999 |
| ht | C | 6 | 0 | 2 | 5 | 9 | 5 | 1 | 02/15/2000 | Swart et al. | 359 | 245 | 11/27/1996 |
| ht | D | 5 | 6 | 4 | 8 | 6 | 1 | 8 | 07/15/1997 | Neukermans et al. | 73 | 862.08 | 01/31/1996 |
| ht | E | 5 | 9 | 9 | 8 | 9 | 0 | 6 | 12/07/1999 | Jerman et al. | 310 | 309 | 08/17/1998 |
| ht | F | 5 | 8 | 8 | 1 | 1 | 9 | 8 | 03/09/1999 | Haake | 385 | 136 | 02/10/1997 |
| ht | G | 5 | 9 | 9 | 5 | 3 | 3 | 4 | 11/30/1999 | Fan et al. | 360 | 106 | 12/30/1997 |
| | H | | | | | | | | | | | | |
| FOREIGN PATENT DOCUMENTS | | | | | | | | | | | | | |
| | | DOCUMENT NUMBER | | | | | | | DATE | COUNTRY | CLASS | SUBCLASS | TRANSLATION YES NO |
| ht | I | 1 | 0 | 3 | 3 | 6 | 0 | 1 | 09/06/2000 | EP | G02B26 | 02 | |
| | J | | | | | | | | | | | | |
| OTHER PRIOR ART (Including Author, Title, Date, Pertinent Pages, Etc.) | | | | | | | | | | | | | |
| ht | K | Zhimin Yao and Noel MacDonald, "Single Crystal Silicon Supported Thin Film Micromirrors for Optical Applications, May 1997, P1408-1413 | | | | | | | | | | | |
| ht | L | Pending U.S. Patent, 09/585,835, "Staggered Torsional Electrostatic Combdribe and Method of Forming Same" | | | | | | | | | | | |
| ht | M | Robert Conant et al., "A Flat High-Frequency Scanning Micromirror," 2000, P1-3 | | | | | | | | | | | |
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